

JUN 10 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. 10/757,253
Confirmation No. 4387
Filing Date January 13, 2004
Inventor Denise M. Eppich
Assignee Micron Technology, Inc.
Group Art Unit 2823
Examiner Hsien-Ming Lee
Attorney's Docket No. MI22-2467
Customer No. 021567
Title: Methods Of Forming Transistor Devices And Capacitor Constructions

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR § 1.8

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9306 on the date shown below:

1. Certificate of Facsimile Transmission
2. Response to March 30, 2005 Office Action

Dated: June 10, 2005By: 

Jennifer Gaines, Legal Assistant
Telephone No. (509) 624-4276
Facsimile No. (509) 838-3424

FEE DEFICIENCY

Although it is believed that no fees are due, the Commissioner is hereby authorized to charge any fees under 37 C.F.R. 1.16 and 1.17 which may be required by this paper to Deposit Account No. 23-0925.

Dated: June 10, 2005By: 

David G. Latwesen, Ph.D.
Reg. No. 38,533

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RESPONSE TO MARCH 30, 2005 OFFICE ACTION

To: Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: David G. Latwesen, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS

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